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Attorney Docket No.: AMAT/6228/CPI/ECP/PJS

Express Mail No.: EL913563821US

Claims

What is claimed is:

1. A method for plating copper on a substrate, comprising adding an anti-oxidant to a plating solution in an amount effective to reduce degradation of organic additives in the plating solution, the anti-oxidant being selected from the group consisting essentially of sodium stannate, hydroquinone, butylated hydroxy toluene, and combinations thereof.

2. The method of claim 1, wherein a concentration of the anti-oxidant is between about 500 ppm and about 5000 ppm.

- 3. The method of claim 2, wherein the plating solution is configured to support copper plating.
- 4. The method of claim 2, wherein the plating solution includes copper ions in a concentration of between about 5 g/L and about 100 g/L.
- 5. The method of claim 2, wherein the plating solution includes an acid in a concentration of between about 5 g/L and about 200 g/L.
- 6. The method of claim 2, wherein the plating solution includes chloride ions in a concentration of between about 10 ppm and about 200 ppm.
- 7. The method of claim 1, wherein the amount of anti-oxidant added into the plating solution per unit time is calculated to correspond to an amount of organic additives degrading in the plating solution per unit time.
- 8. The method of claim 1/, wherein the plating solution comprises: copper ions at a concentration of between about 5 g/L and about 100 g/L; an acid at a concentration of between about 5 g/L and about 200 g/L;

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chloride ions at a concentration of between about 10 ppm and about 200 ppm;

sodium stannate at a concentration of between about 500 ppm and about 5000 ppm; and

at least one organic plating additive configured to enhance a plating characteristic of the metal on the substrate.

9. The method of claim 8, wherein the at least one organic plating additive comprises at least one of a leveler, a suppressor, and an accelerator.

The method of claim 1, further comprising: disposing of the entire plating solution after a period of time; and replacing the plating solution.

11. A method for plating metal on a substrate, comprising:
disposing the substrate and an anode in a plating solution, the plating solution

comprising:

metal ions;

one or more organic additives configured to enhance one or more plating characteristics; and

at least one anti-oxidant in an amount effective to reduce degradation of the one or more organic additives; and

plating metal ions from the plating solution onto the substrate.

- 12. The method of claim 11, further comprising:
 disposing of the entire plating solution after a period of time; and replacing the plating solution.
- 13. The method of claim 11, wherein the metal ions comprise copper.

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14. The method of claim 11, wherein the metal ions comprise copper in a concentration between about 5 g/L and/about 100 g/L.

15. The method of claim 11, wherein the at least one anti-oxidant is selected from the group consisting essentially of socium stannate, hydroquinone, and butylated hydroxy toluene.

16. The method of claim 11, wherein the anti-oxidant is sodium stannate at a concentration of between about 500 ppm and about 5000 ppm.

17. The method of claim 16, wherein the plating solution further comprises chloride ions at a concentration of between about 10 ppm and about 200 ppm.

18. The method of claim 16, wherein the plating solution further comprises an acid at a concentration of between about 5 g/L and about 500 g/L.

19. The method of claim 11, wherein the plating solution comprises:
copper ions at a concentration of between about 5 g/L and about 100 g/L;
an acid at a concentration of between about 5 g/L and about 200 g/L;
chloride ions at a concentration of between about 10 ppm and about 200
ppm; and

sodium stannate at a concentration of between about 500 ppm and about 5000 ppm.

20. A plating solution for an electrochemical plating system, comprising: a liquid solution containing copper ions to be plated on a substrate;

at least one organic plating additive configured to facilitate a plating characteristic of the copper ions onto a substrate; and

at least one anti-oxidant in an amount sufficient to reduce the degradation of the at least one organic plating additive in the plating solution.

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21. The plating solution of claim 20, wherein the liquid solution comprises copper sulfate.

22. The plating solution of claim 20, wherein the copper ions are at a concentration of between about 5 g/L and about 100 g/L.

23. The plating solution of claim 22, further comprising an acid at a concentration of between about 5 g/L and about 200 g/L.

- 24. The plating solution of claim 22, further comprising chloride ions at a concentration of between about 10 ppm and about 200 ppm.
- 25. The plating solution of claim 20, wherein the at least one anti-oxidant is selected from the group consisting essentially of sodium stannate, hydroquinone, and butylated hydroxy toluene.
- 26. The plating solution of claim 22, wherein the anti-oxidant is sodium stannate at a concentration of between about 500 ppm and about 5000 ppm.
- 27. The plating solution of claim 20, further comprising; copper ions at a concentration of between about 5 g/L and about 100 g/L; an acid solution at a concentration of between about 5 g/L and about 200 g/L; chloride ions at a concentration of between about 10 ppm and about 200 ppm; and

sodium stannate at a concentration of between about 500 ppm and about 5000 ppm.

28. The plating solution of claim 20, wherein the at least one organic plating additive comprises at least one of a suppressor, leveler, and an accelerator.

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degraded /organic plating 29. A method for reducing additives electrochemical plating solution, comprising adding sodium stannate to the electrochemical plating solution, the sodium stannate being added in an amount corresponding to a time varying amount/of degraded organic plating additives generated in the electrochemical plating solution.

30. The method of claim 29, wherein a concentration of the sodium stannate is between about 500 ppm and about 5000 ppm.

- The method of claim 29, wherein the electrochemical plating solution is configured to plate copper.
- The method of claim 31, wherein the electrochemical plating solution includes 32. copper ions in a concentration of between about 5 g/L and about 100 g/L.
- 33. The method of claim \$1, wherein the electrochemical plating solution includes an acid in a concentration of between about 5 g/L and about 200 g/L.
- 34. The method of claim 31, wherein the plating solution includes chloride ions in a concentration of between about 10 ppm and about 200 ppm.
- A method for plating copper in an electrochemical plating system, comprising 35. contacting a substrate having an electrical bias applied thereto with a plating solution, wherein the plating solution domprises a copper source, at least one organic additive, and at least one anti-oxidant selected from the group consisting of sodium stannate, hydroquinone, but lated hydroxy toluene, and combinations thereof.
- 36. The method of claim/35, wherein a concentration of the sodium stannate is between about 500 ppm and about 5000 ppm.

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- 37. The method of claim 36, wherein the plating solution includes copper ions supplied by a copper sulfate solution, wherein the copper ions are in a concentration of between about 5 g/L and about 100 g/L.
- 38. The method of claim 36, wherein the plating solution includes an acid in a concentration of between about 5 g/L and about 200 g/L.
- 39. The method of claim 36, wherein the plating solution includes chloride ions in a concentration of between about 10 ppm and about 200 ppm.
- 40. The method of claim 36, wherein the amount of anti-oxidant added into the plating solution per unit time is calculated to correspond to an amount of organic additives degrading in the plating solution per unit time.